## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:	)	
	:	Examiner: R. E. Fuller
Youzou FUKAGAWA	)	
	:	Group Art Unit: 2851
Application No.: 10/623,542	)	
	:	Confirmation No.: 4887
Filed: July 22, 2003	)	
	:	Allowed: November 18, 2004
For: DISTORTION MEASUREMENT	)	
METHOD AND EXPOSURE APPARATUS	:	February 18, 2005

**Mail Stop RCE** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: